

Nanophotonics & Nanomechanics

Alexander Bruch

Hong Tang Lab

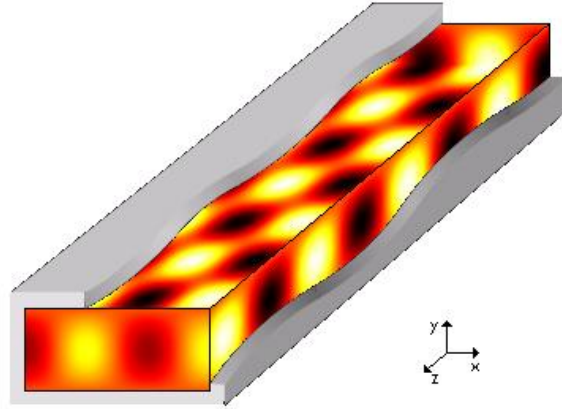
Department of Electrical Engineering

<https://www.eng.yale.edu/tanglab/>

Hose:
Guides “Water Waves”

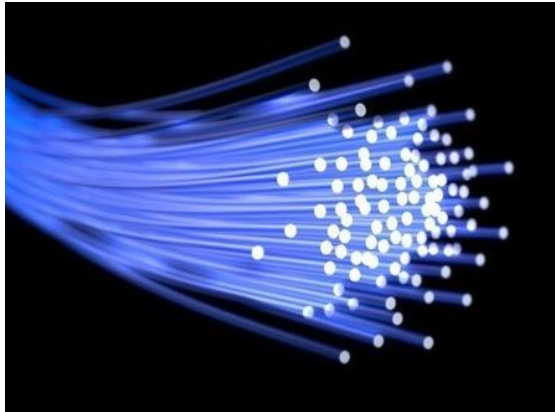


Optical Waveguide:
Guides Optical Waves



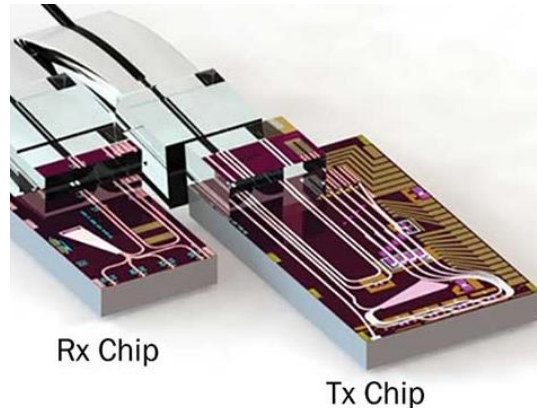
Bulk Waveguides

Optical Fiber: ~50 GBps



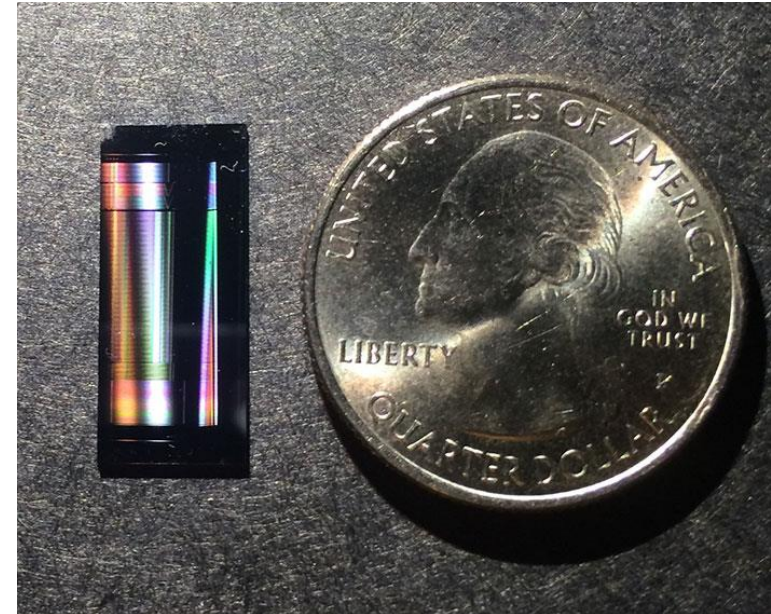
Integrated Waveguides

Silicon Chip: ~500 GBps



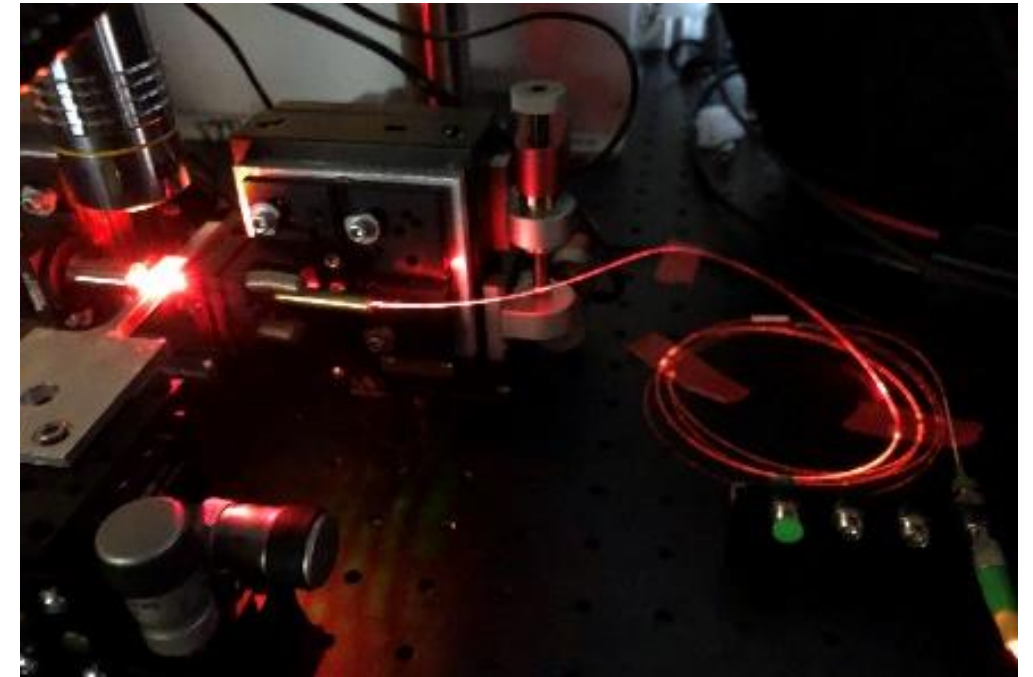
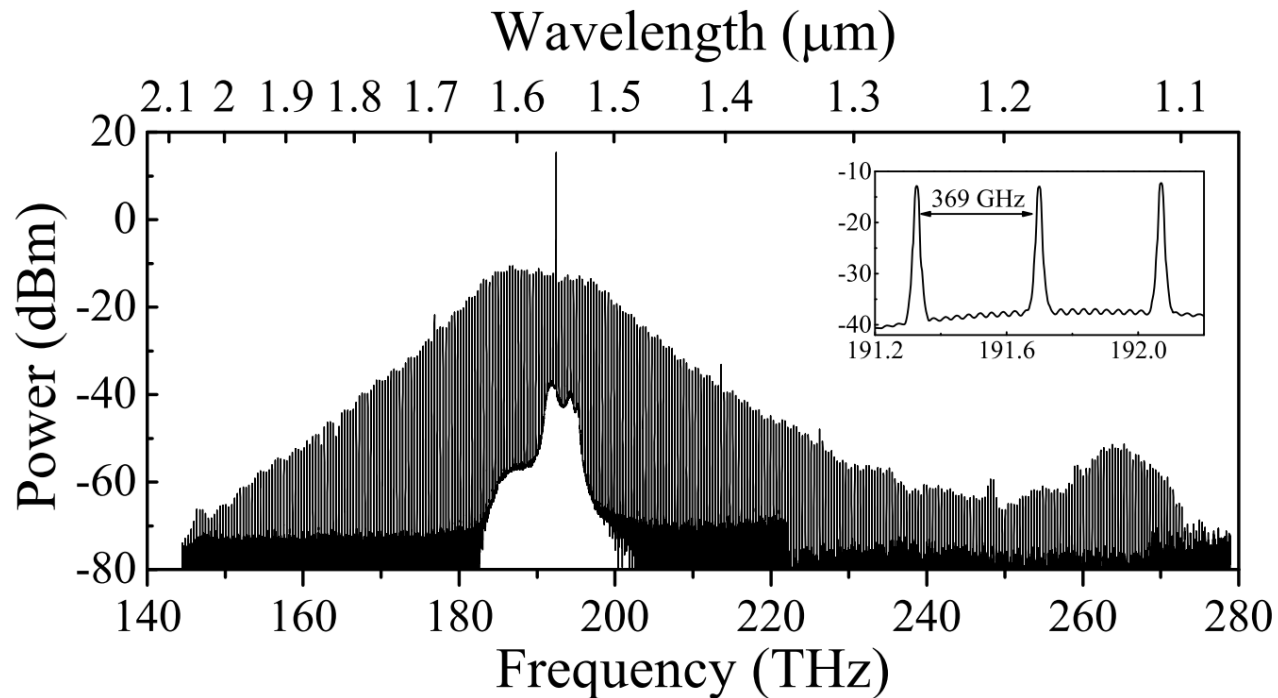
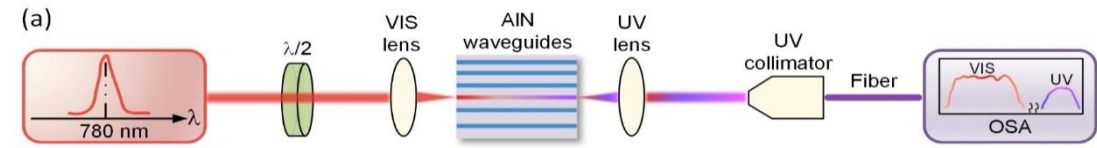
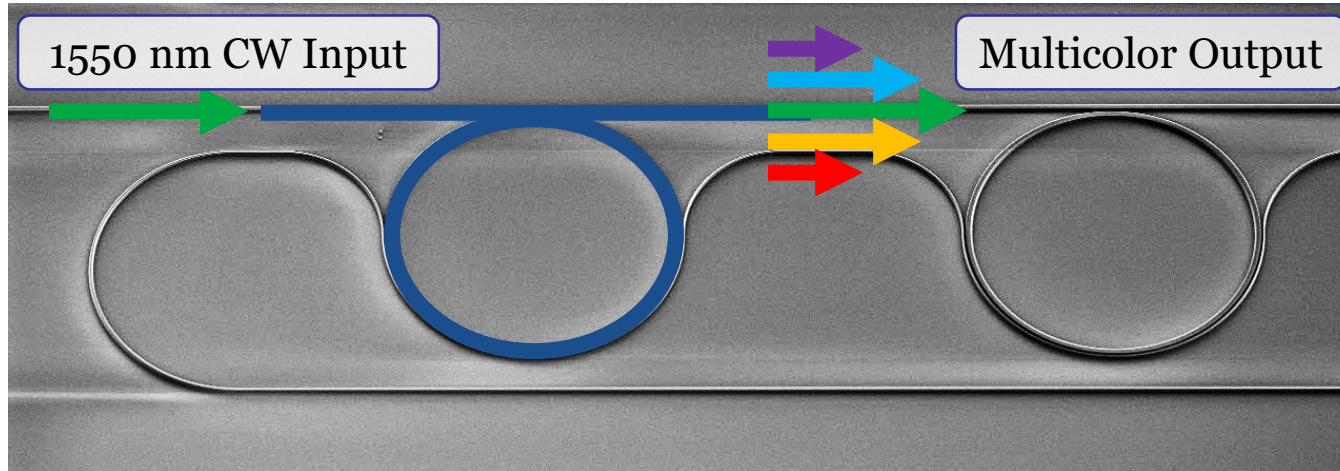
Research activities in Tang Lab

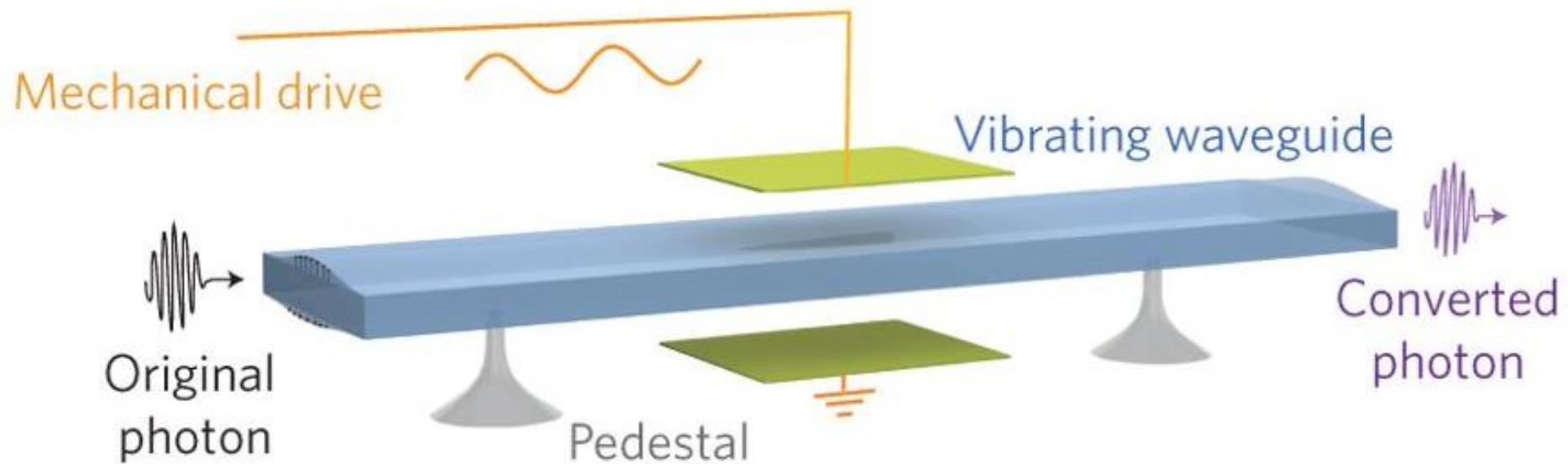
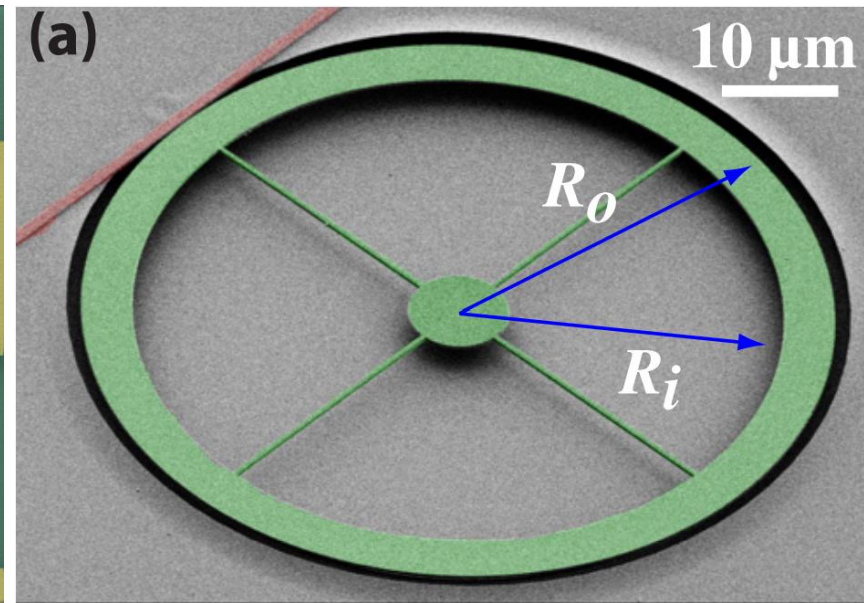
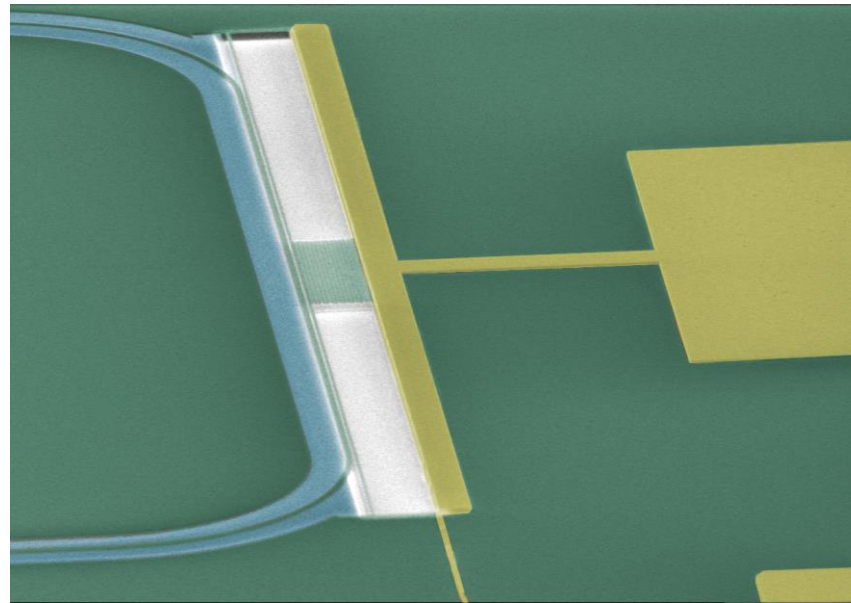
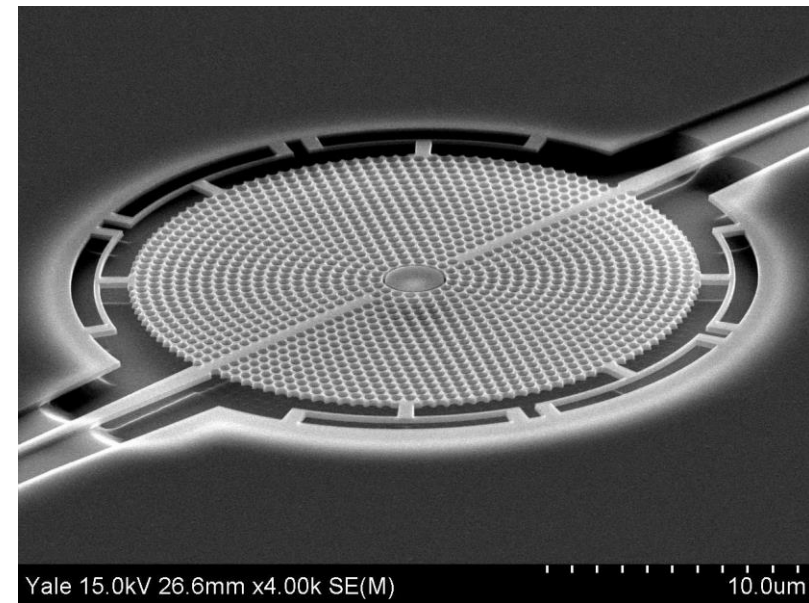
- Integrated Nonlinear Optics & Frequency Combs
- Cavity Optomechanics
- Integrated Quantum Photonic Circuits
- Superconducting Devices & Single Photon Detectors



Nonlinear Optics and Frequency Combs

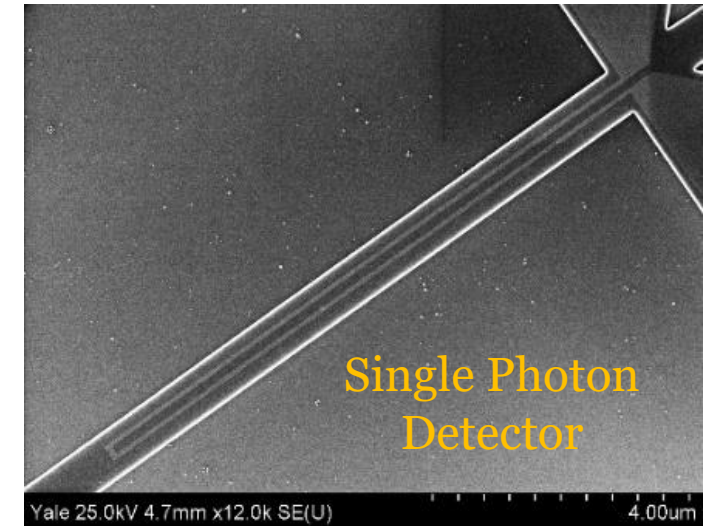
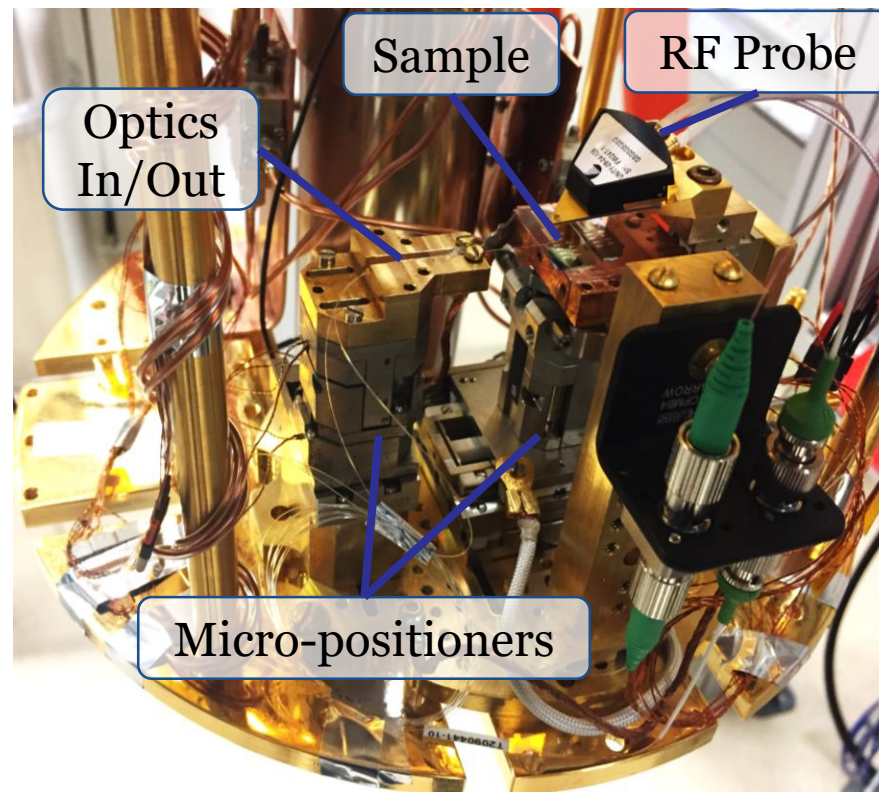
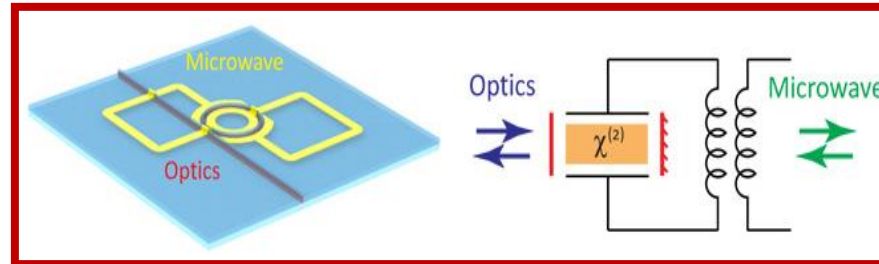
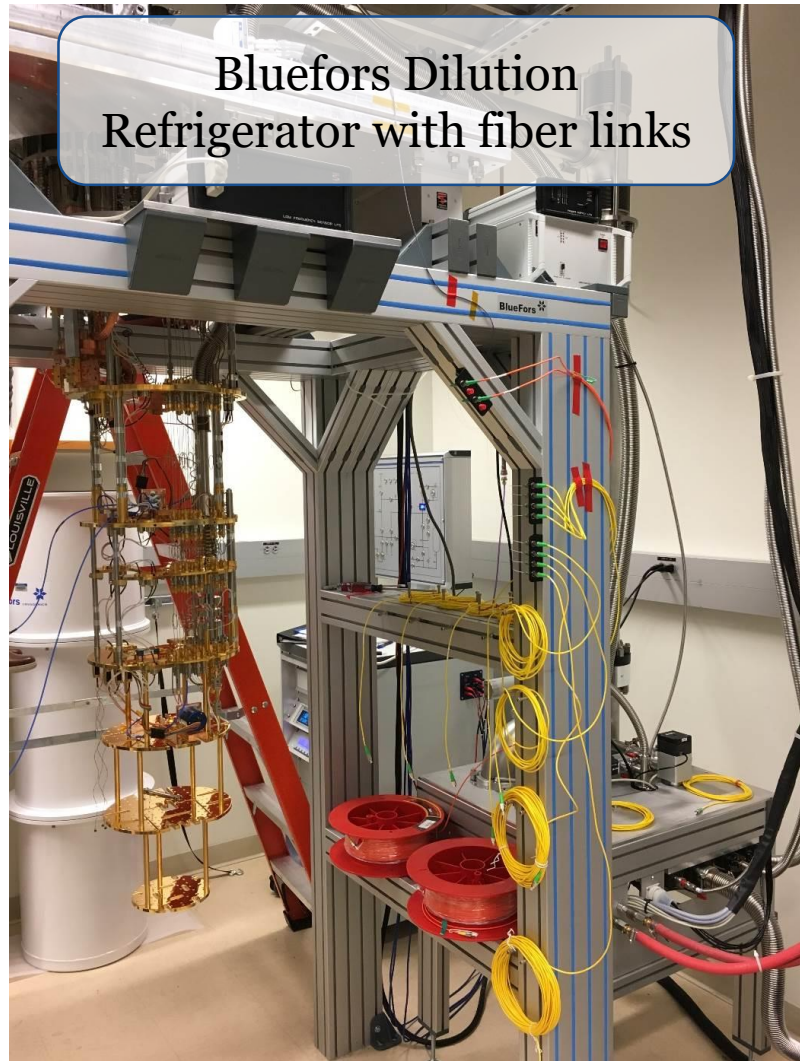
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Microwave-to-Optical Quantum Frequency Conversion

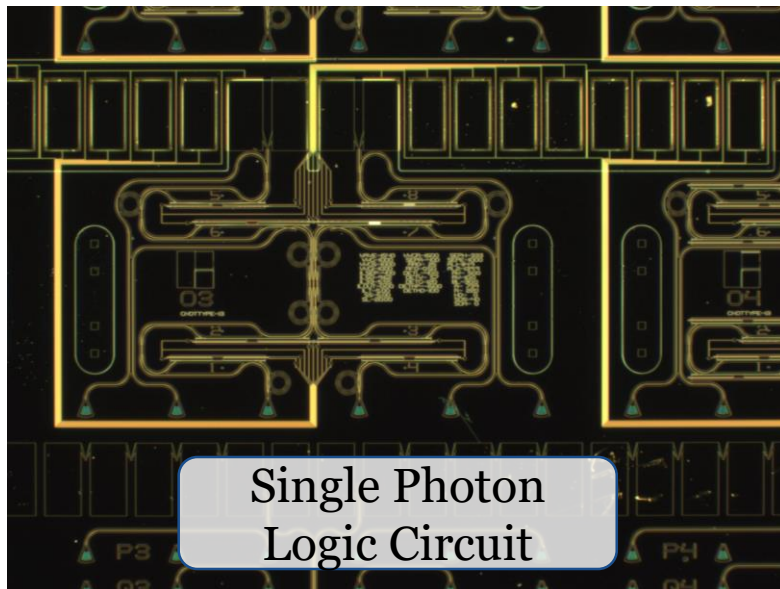
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Instrumentation Needs & Expertise Yale

Fabricating Photonic Chips

- “Intel-Level Capabilities on an NSF-Level Budget”
- Full Silicon/ III-V chip fabrication flow
- Nanoscale Processing Tolerance
- **Current instrument needs**
 - E-beam deposition systems (aging)
 - E-beam lithography systems (aging)
 - Wafer bonder
 - Chemical mechanical polisher



Yale SEAS Cleanroom



Hitachi SU-70 Scanning
Electron Microscopy



Raith EBPG 5000+
Ebeam Lithography

